

Sheet 1 of 1 .

Application Number

10/090,470

Schultz et al.

Filing Date

Group Art Unit

March 4, 2002

2882

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

DEC 11 2003

(Use several sheets if necessary)

U. S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)

Murphy et al., "Synchrotron Radiation Sources and Condensers for Projection X-Ray Lithography", APPLIED OPTICS, Vol. 32, No. 34, pp.6920-6929 (1 December 1993)

"Handbook on Synchrotron Radiation", Ernst-Echard Koch ed., pp.140-145, 1098-1111 (1983)

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.